

Electronic Patent Application Fee Transmittal

Application Number:	10568461			
Filing Date:	15-Feb-2006			
Title of Invention:	SEMICONDUCTOR DEVICE, METHOD FOR MANUFACTURING SEMICONDUCTOR DEVICE AND GAS FOR PLASMA CVD			
First Named Inventor/Applicant Name:	Yasuo Kobayashi			
Filer:	Michael A. Makuch/Cynthia Johnson			
Attorney Docket Number:	33082M300			
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Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
Basic Filing:				
Pages:				
Claims:				
Miscellaneous-Filing:				
Petition:				
Patent-Appeals-and-Interference:				
Post-Allowance-and-Post-Issuance:				
Utility Appl issue fee	1501	1	1510	1510
Publ. Fee- early, voluntary, or normal	1504	1	300	300

Description	Fee Code	Quantity	Amount	Sub-Total in USD(\$)
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Printed copy of patent - no color	8001	4	3	12
Total in USD (\$)				1822